1.	Application No.	Applicant(s)
Notice of Allowability	10/006,180	CHANG ET AL.
Troube of Anowability	Examiner	Art Unit
	Alonzo Chambliss	2827
The MAILING DATE of this communication apperature All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not included
1. This communication is responsive to application filed on 12. The allowed claim(s) is/are 1-20.		
 3. ☐ The drawings filed on are accepted by the Examined 4. ☒ Acknowledgment is made of a claim for foreign priority und a) ☒ All b) ☐ Some* c) ☐ None of the: 	r. er 35 U.S.C. § 119(a)-(d) or (f).	
1. ☑ Certified copies of the priority documents have been received.		
2. Certified copies of the priority documents have been received in Application No		
3. Copies of the certified copies of the priority documents have been received in this national stage application from the		
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
5. Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).		
(a) ☐ The translation of the foreign language provisional application has been received.		
6. Acknowledgment is made of a claim for domestic priority un	der 35 U.S.C. §§ 120 and/or 121.	
Applicant has THREE MONTHS FROM THE "MAILING DATE" of the below. Failure to timely comply will result in ABANDONMENT of the submit of the subm	tted Note the etteched EXAMINED	O AMENDATIVE
INFORMAL PATENT APPLICATION (PTO-152) which gives reason	n(s) why the oath or declaration is d	leficient.
8. CORRECTED DRAWINGS must be submitted.		
(a) including changes required by the Notice of Draftsperso	on's Patent Drawing Review (PTO-9	948) attached
1) ⊠ hereto or 2)		
(b) ☐ including changes required by the proposed drawing correction filed, which has been approved by the Examiner.		
(c) \square including changes required by the attached Examiner's	Amendment / Comment or in the Of	ffice action of Paper No
Identifying indicia such as the application number (see 37 CFR 1.8 of each sheet. The drawings should be filed as a separate paper w	4(c)) should be written on the drawing rith a transmittal letter addressed to th	gs in the top margin (not the back) ne Official Draftsperson.
9. DEPOSIT OF and/or INFORMATION about the deposi attached Examiner's comment regarding REQUIREMENT FOR TH	t of BIOLOGICAL MATERIAL mi E DEPOSIT OF BIOLOGICAL MATI	ust be submitted. Note the ERIAL.
Attachment(s)		
 1⊠ Notice of References Cited (PTO-892) 3⊠ Notice of Draftperson's Patent Drawing Review (PTO-948) 5⊠ Information Disclosure Statements (PTO-1449), Paper No. 2. 7□ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	4∐ Interview Summar 6∐ Examiner's Amend	Patent Application (PTO-152) y (PTO-413), Paper No dment/Comment nent of Reasons for Allowance

Art Unit: 2827

Page 2

DETAILED ACTION

Allowable Subject Matter

1. The following is a statement of reasons for the indication of allowance subject matter: the prior art of record does not teach or suggest the combination of a semiconductor chip having electrode pads with a first electric layer overlying the chip. A first metal layer on the first electric layer, wherein a second dielectric layer is on the first metal layer. A second metal layer is on the second dielectric layer, wherein one of the first and second metal layers comprising a ground metal layer having a plate structure.

Any inquiry concerning the communication or earlier communications from the examiner should be directed to Alonzo Chambliss whose telephone number is (703) 306-9143. The fax phone number for the Group is (703) 308-772 or 7724.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the group receptionist whose telephone number is (703) 308-7956.

DAVID L. TALBOTT

SUPERVISORY PATENT EXAMINER

TECHNOLOGY CENTER 2800

AC/March 9, 2003